

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Vladimir Pavlovich POPOV, et al.

Serial No.: 10/542,123 Group No.: 2823

Filed: December 9, 2005 Examiner: Q. Jefferson

For: METHOD FOR PRODUCING A SILICON-ON-INSULATOR STRUCTURE

Attorney Docket No.: U 015850-2

Commissioner for Patents  
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